IN THE UNITED STATES PATENT AND TRADEMARK OFFICE BEFORE THE PATENT TRIAL AND APPEAL BOARD

In repatent of: Chistyakov Petition for Inter Partes Review

U.S. Patent No. 6,853,142 Attorney Docket No.: 34789.98

Issued: February 8, 2005 Customer No.: 27683

Title: Methods and Apparatus for Real Party in Interest: Fujitsu

Generating High-Density Plasma Semiconductor Limited and Fujitsu

Semiconductor America, Inc.

PETITIONER POWER OF ATTORNEY PURSUANT TO 37 CFR 42.10(b) FOR PETITION FOR INTER PARTES REVIEW

Petitioners Fujitsu Semiconductor Limited and Fujitsu Semiconductor America, Inc. hereby appoints the Practitioner(s) associated with Customer Number 27683, as its attorney(s) to prosecute and to transact all business in the Patent Trial & Appeal Board of the United States Patent and Trademark Office connected with Inter Partes Review of the above-identified patent.

Please direct all communication regarding this Petition to Customer Number 27683:

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USPTO Customer No. 27683 USPTO Customer No. 27683 USPTO Reg. No. 42,044 USPTO Reg. No. 32,271

The undersigned is authorized to sign this Power of Attorney on behalf of the Petitioners.

Fujitsu Semiconductor Limited Fujitsu Semiconductor America, Inc.

Takashi Kikuma Takashi Kikuma

Director, IP Licensing Department

General Counsel & Corporate Secretary Intellectual Property Unit

